



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

DUANE C. GATES

U.S. Patent Application No. 09/534,814

: Group Art Unit: 3742

Filed: March 22, 2000

: Examiner: PASCHALL, Mark

For: SEGMENTED COIL FOR GENERATING PLASMA IN PLASMA PROCESSING EQUIPMENT

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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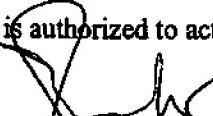
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STATEMENT UNDER 37 CFR 3.73(b) TECHNOLOGY CENTER R3700

Applicant/Patent Owner: LAM RESEARCH CORPORATION

LAM RESEARCH CORPORATION a Delaware Corporation, states that it is the assignee of the entire right, title and interest on the patent application identified above by virtue of an assignment from the inventors of the parent patent application to the one identified above. The assignment in the parent application (Application Number 08/507,971 – US Patent Number 5,731,565) was recorded in the United States Patent and Trademark Office at Reel 7698, Frame 0478, a copy of which is attached.

The undersigned (whose title is supplied) is authorized to act on behalf of the assignee.



Jeffrey Brooks
Assistant Secretary
Director of Intellectual Property
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DATED: 18 July 03